

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|------------------------------------|---|-------------------------|
| In re Application of: Tilke et al. |) | Group Art Unit: 2811 |
| |) | |
| Attorney Docket No. 1890-0061 |) | Confirmation No.: 7063 |
| |) | |
| Application No.: 10/780,276 |) | Examiner: Thien F. Tran |
| |) | |
| Filed: February 17, 2004 |) | |
| |) | |
| For: Semiconductor Structure With |) | |
| Increased Breakdown Voltage and |) | |
| Method for Producing the |) | |
| Semiconductor Structure |) | |

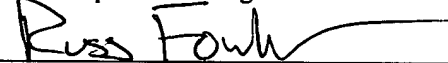
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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July 5, 2005

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AMENDMENT & RESPONSE

Sir:

In response to the Office action of May 3, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.